PATENT Docket No. 150.00810102

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE							
Applicant(s):	Brian A. Vaarstra	)	Group Art U		FAX RECEIVED		
Serial No.: Confirmation	09/865,612 No.: 4967	) )	Examiner:	G. Fourson III	FEB 2 8 2003		
Filed:	May 25, 2001	)			TECHNOLOGY CENTER 2800		
For:	METHODS, COMPL CONTAINING FILM	EXES, AND S	SYSTEMS FO	R FORMING M STRUCTURES	ETAL-		
FACSIMILE TRANSMISSION TO THE PTO							
	mmissioner for Patents er <u>G. Fourson III</u> D.C. 20231		Total Pages Time: /:	SER: (703)308- (including cover (2000 (Centron must be completed) stern time.)	page): <u>20</u> al Time)		
The following papers are being transmitted to the Patent and Trademark Office by facsimile transmission: Response (4 pgs.): Exhibit A (3 pgs.); Supplemental Information Disclosure Statement (2 pgs.); 1449 Form (1 pg.); and copy of 1 cited document (9 pgs.)  PLEASE CHARGE DEPOSIT ACCOUNT NO. 13-4895 IN THE AMOUNT							
PLEASE	OF \$180.00	TO COVE	R SUPPLEN	MENTAL	77		
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Date	·	Reg.	n D. Albin No. 37,763 ct Dial (612)30	05-1225			
described herein addressed to As-	-03	e undersigned here facsimile in accor s, Washington, D.  Signature:  Name:  Ji	by certifies that thi dance with 37 CFR C. 20231, on this lentral Time).	s Facsimile Cover Shee \$ §1.6(d) to the Patent a	et and the paper(s), as and Trademark Office		
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PATENT Docket No. 150.00810102 6 5 43

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Brian A. Vaartstra	) Group Art	Unit: 2823
Serial No.: Confirmation	09/865,612 No.: 4697	) Examiner:	G. Fourson III
Filed:	May 25, 2001	) ) }	
For:	METHODS, COMPLEXES, . CONTAINING FILMS ON S		

### RESPONSE

Assistant Commissioner for Patents Washington D.C. 20231

Dear Sir:

In response to the Office Action mailed December 3, 2002, please consider the following remarks:

#### Remarks

The Office Action mailed December 3, 2002 has been received and reviewed. Reconsideration and withdrawal of the rejections are respectfully requested.

#### Rejection under 35 U.S.C. §102

The Examiner rejected claims 18-38 under 35 U.S.C. §102(a) as being anticipated by the Examiner's Taking of Official Notice. Specifically, the Examiner has taken Official Notice that "CVD systems including those adapted as recited in claim 20 for example were known prior to applicant's invention." Applicant respectfully traverses the rejection.

"[F]or anticipation under 35 U.S.C. 102, the reference must teach every aspect of the claimed invention either explicitly or impliedly." M.P.E.P. §706.02 (emphasis added). Independent claims 18, 19, 33, and 38 each recite, among other things, a chemical vapor deposition system including a vessel containing a precursor including one or more complexes of the formula:  $[(R^l)NC(R^2)C(R^3)N(R^4)]ML_{\nu}$ .